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Claims:

1. A ferroelectric device, comprising:

a prestress layer placed on a mold;

a ferroelectric layer placed on the prestress layer, such that a layered structure is created;

means for heating the prestress and ferroelectric layers; and means for cooling the prestress and ferroelectric layers such that the heating and cooling means induce a prestress into the layered structure.

2. The method of claim 1, wherein the prestress layer includes reinforcing material.

3. The method of claim 1 wherein the ferroelectric layer includes surface electrodes.

4. The method of claim 1, further comprising:

an electrode layer placed between the prestress layer and the ferroelectric layer; and

an electrode layer placed on top of the ferroelectric layer.

5. The method of daim 1 wherein the prestress layer is an adhesive.

6. The method of claim 1 wherein the ferroelectric layer is a piezoelectric material.

7. The method of claim 1 wherein the ferroelectric layer is a piezostrictive material.

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PATENT APPLICATION

8. The method of claim 1 wherein the ferroelectric layer is formed from a composite.

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